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CENTRAL FAX CENTER****JUL 05 2005****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Venkat Selvamanickam, et al.

Title: APPARATUS FOR AND METHOD OF CONTINUOUS HTS TAPE  
BUFFER LAYER DEPOSITION USING LARGE SCALE ION BEAM  
ASSISTED DEPOSITION

App. No.: 10/609,250

Filed:

June 26, 2003

Examiner: Ram N. Kackar

Group Art Unit: 1763

Atty. Dkt. No.: 1014-SP101-US

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**MS AMENDMENT**

Commissioner for Patents

PO Box 1450

Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Dear Sir:

Prior to the first action on the merits, please amend the above-identified application as follows:

Pat. App. No.: 10/609,250